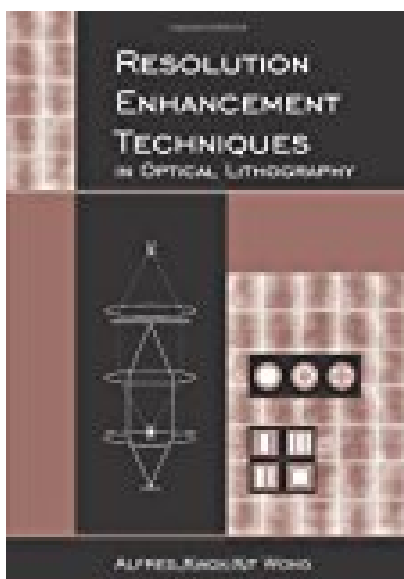


# Resolution Enhancement Techniques in Optical Lithography SPIE Tutorial Texts in Optical Engineering Vol. TT47

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